



**ELECTRONIC COPY**

LG784623339  
Report verification at igi.org



March 23, 2026  
IGI Report Number **LG784623339**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **SQUARE EMERALD CUT**  
Measurements **5.87 X 5.78 X 4.00 MM**

**GRADING RESULTS**

Carat Weight **1.23 CARAT**  
Color Grade **E**  
Clarity Grade **SI 1**

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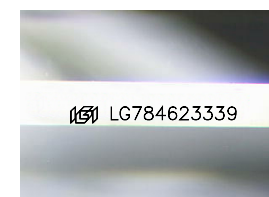
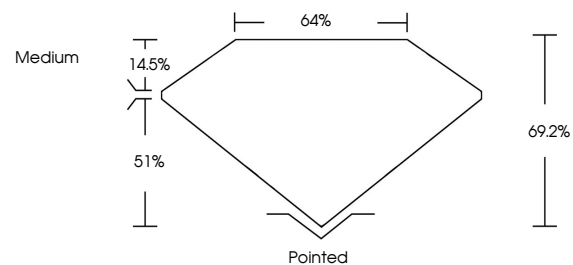
Carat Weight **1.23 CARAT**  
Color Grade **E**  
Clarity Grade **SI 1**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG784623339**

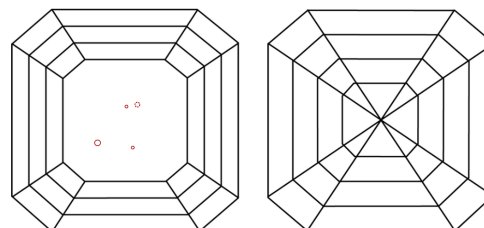
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

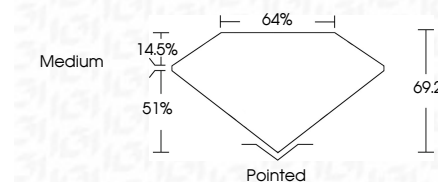
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



March 23, 2026  
IGI Report No **LG784623339**  
**SQUARE EMERALD CUT**  
Carat Weight **1.23 CARAT**  
Color Grade **E**  
Clarity Grade **SI 1**  
Depth **51%**  
Table **14.5%**  
Girdle **64%**  
Medium  
Culet **Pointed**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG784623339**  
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Type IIa